## **REMARKS**

The Final Office Action mailed September 28, 2006, has been received and reviewed.

Claims 1 through 9 are currently pending in the application. Claims 1 through 9 stand rejected.

Applicant proposes to amend claim 1, and respectfully requests reconsideration of the application as proposed to be amended herein.

# 35 U.S.C. § 102(e) Anticipation Rejections

Anticipation Rejection Based on U.S. Patent No. 6,747,465 to Esashi et al.

Claims 1 through 8 stand rejected under 35 U.S.C. § 102(e) as being anticipated by Esashi et al. (U.S. Patent No. 6,747,465). Applicant respectfully traverses this rejection, as hereinafter set forth.

A claim is anticipated only if each and every element as set forth in the claim is found, either expressly or inherently described, in a single prior art reference. *Verdegaal Brothers v. Union Oil Co. of California*, 2 USPQ2d 1051, 1053 (Fed. Cir. 1987). The identical invention must be shown in as complete detail as is contained in the claim. *Richardson v. Suzuki Motor Co.*, 9 USPQ2d 1913, 1920 (Fed. Cir. 1989).

Applicant submits that the Esashi reference does not and cannot anticipate under 35 U.S.C. § 102 the presently claimed invention of independent claim 1, and claims 2-8 depending therefrom, because the Esashi reference does not describe, either expressly or inherently, the identical inventions in as complete detail as are contained in the claims.

#### The Office Action alleges:

Esashi teaches the following claimed limitations as cited below:

- 1.(Original) A method for electrically coupling a first side of a semiconductor substrate to a second side of said semiconductor substrate, comprising:
- forming a hole having an inner surface from a first side of a semiconductor substrate to a second side of said semiconductor substrate (Fig. 8E (11D)); and
- plating said inner surface of said semiconductor substrate to form a plated conductive element by forcing a plating solution from said first side of said semiconductor substrate to said second side of said semiconductor substrate through said hole (Fig. 8H (12)). (Office Action, pp. 2-3; emphasis added.)

The Esashi reference discloses no such thing. Furthermore, Applicant respectfully disagrees that the Esashi reference anticipates Applicant's invention as claimed in amended independent claim 1 which reads:

A method for electrically coupling a first side of a semiconductor substrate to a second side of said semiconductor substrate, comprising:
forming a hole having an inner surface from a first side of a semiconductor substrate to a second side of said semiconductor substrate; and

plating said inner surface of said semiconductor substrate to form a plated conductive element by forcing a plating solution from said first side of said semiconductor substrate and exiting said plating solution from said second side of said

A clear reading of the Esashi reference discloses a plating method that is contrary to Applicant's invention as presently claimed. As stated, Applicant's invention as presently claimed recites, "plating ... by forcing a plating solution from said first side of said semiconductor substrate and exiting said plating solution from said second side of said semiconductor substrate through said hole." In contrast, the Esashi reference clearly discloses plating performed on a single side since the hole that is to be plated is first sealed closed on the second side thereby prohibiting "plating ... by forcing a plating solution from said first side of said semiconductor substrate and exiting said plating solution from said second side of said semiconductor substrate through said hole" as claimed by Applicant.

semiconductor substrate through said hole. (Emphasis added.)

Specifically, the Esashi reference discloses:

... As shown in FIG. 8D, by reactive ion etching, the exposed seed layer 11 and the underlying Pyrex glass are removed to form a through hole 11D having a forward-tapered cross section (such as shown in FIG. 8E). After the nickel-plated layer 11C is removed by an etchant (e.g., aqua regia, etc.) as shown in FIG. 8F, a metal plate 11E is applied to the back side of the contactor board 11 as shown in FIG. 8G. This metal plate covers the smaller opening of the through hole 11D. By conducting electrolytic plating using the metal plate 11E as an electrode, nickel metal is buried into the through hole from the right side of the contactor board 11 as shown in FIG. 8H, thus forming the conductive member 12. The metal plate 11E is flaked off from the contactor board. (Esashi, col. 8, lines 50-63; emphasis added.)

Not only does the Esashi reference lack disclosure of "plating ... by forcing a plating solution from said first side of said semiconductor substrate and exiting said plating solution from said second side of said semiconductor substrate through said hole", the Esashi reference also lacks disclosure of Applicant's claimed invention of "[a] method for electrically coupling a first side of a semiconductor substrate to a second side of said semiconductor substrate".

Specifically in the Esashi reference, once the "nickel metal is buried into the through hole" and "metal plate 11E is flaked off from the contactor board", no electrical connection for "coupling a first side of a semiconductor substrate to a second side of said semiconductor substrate" is possible as electrically conductive plating was prohibited from occurring on the second side.

Therefore, the Esashi reference cannot describe Applicant's claimed element of the invention of "[a] method for electrically coupling a first side of a semiconductor substrate to a second side of said semiconductor substrate".

Therefore, independent claim 1, and claims 2-8 depending therefrom, cannot be anticipated by the Esashi reference under 35 U.S.C. § 102. Accordingly, such claims are allowable over the cited prior art and Applicant respectfully requests that such rejections be withdrawn.

## 35 U.S.C. § 103(a) Obviousness Rejections

Obviousness Rejection Based on U.S. Patent No. 6,747,465 to Esashi et al.

Claim 9 stands rejected under 35 U.S.C. § 103(a) as being unpatentable over Esashi et al. (U.S. Patent No. 6,474,465). Applicant respectfully traverses this rejection, as hereinafter set forth.

The nonobviousness of independent claim 1 precludes a rejection of claim 9 which depends therefrom because a dependent claim is obvious only if the independent claim from which it depends is obvious. See In re Fine, 5 U.S.P.Q.2d 1596, 1600 (Fed. Cir. 1988), see also MPEP § 2143.03. Therefore, the Applicant requests that the Examiner withdraw the 35 U.S.C. § 102 rejection to independent claim 1 and claim 9 which depends therefrom.

#### **ENTRY OF AMENDMENTS**

The proposed amendments to claim 1 above should be entered by the Examiner because the amendments are supported by the as-filed specification and drawings and do not add any new matter to the application. Further, the amendments do not raise new issues or require a further search. Finally, if the Examiner determines that the amendments do not place the application in condition for allowance, entry is respectfully requested upon filing of a Notice of Appeal herein.

### **CONCLUSION**

Claims 1-9 are believed to be in condition for allowance, and an early notice thereof is respectfully solicited. Should the Examiner determine that additional issues remain which might be resolved by a telephone conference, he is respectfully invited to contact Applicant's undersigned attorney.

Respectfully submitted,

Kevin K. Johanson

Registration No. 38,506

Attorney for Applicant

TRASKBRITT

P.O. Box 2550

Salt Lake City, Utah 84110-2550

Telephone: 801-532-1922

Date: December 4, 2006

KKJ/djp:lmh Document in ProLaw